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REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 2800

Attorney Docket No. 002013.P135

D
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

9/7/05
In Re Application of:

Seong Hyun Kim, et al.

Filed: November 25, 2003

Serial No: 10/722,818

For: VERTICAL STRUCTURE THIN
FILM TRANSISTOR

Examiner: Tuan N. Quach

Art Unit: 2814

Mail Stop AF
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Dear Commissioner:

In connection with the Final Office Action mailed May 25, 2005, regarding the above-referenced application, Applicant respectfully requests consideration of the following amendments and remarks below.